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APPLICANT'S ART CITATION (Use several sheets if necessary)	Application AP 2004-170777 OFGS File No. 10/573605
	Applicant Johannes WEIERMAIR et al.
	Filing Date _____ Group Art Unit _____

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-4,392,759	07-1983	Cook	403	11	
	US-3,926,532	12-1975	Schlenker et al.	403	322	
	US-2,697,335	12-1954	Peterson	64	8	
	US-5,000,024	03-1991	Seidl et al.	72	249	
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FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	DE 101 58 711 A1	06-2003	Germany			abstract	
	EP 0 728 538 A1	08-1996	Europe			abstract	
	DE 4035941	05-1992	Germany			abstract	
	DE 195 08 526	09-1996	Germany			abstract	
	GB 2 288 003 A	10-1995	United Kingdom			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	International Search Report PCT/EP2004/009679 dated 19 November 2004

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